

INFORMATION DISCLOSURE CITATION*(Use several sheets if necessary)*

Docket number (Optional)

15689.49.5

Application Number

10/673,658

Applicant(s)

Takehiro Nakamura et al.

Filing Date

September 29, 2003

Group Art Unit

2611

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

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FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	1	0 682 418 A2	05/12/1995	EPO	H0487	005	X	
	2	CN1126930	7/17/1996	China	H04B7	005	X	

EXAMINER

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Initial****OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)****3****Chinese Office Action for Chinese Patent Application No.: 20031010330.1****EXAMINER****DATE CONSIDERED****EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.**